



UNITED STATES PATENT and TRADEMARK OFFICE

UNDER SECRETARY OF COMMERCE FOR INTELLECTUAL PROPERTY AND
DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
WWW.USPTO.GOV

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In re Application of: :
Atsushi Shiota, et al. :
Serial No. 09/770,289 : NOTICE OF WITHDRAWAL
Filed: January 29, 2001 : FROM ISSUE UNDER
For: PROCESS FOR PRODUCING : 37 CFR 1.313 (b)
SILICA-BASED FILM, SILICA-BASED :
FILM, INSULATING FILM, AND SEMI- :
CONDUCTOR DEVICE :

The above-identified application is withdrawn from issue after payment of the issue fee due to: reopening of prosecution. See 37 CFR 1.31(b).

The above-identified application is hereby withdrawn from issue.

The issue fee is refundable upon written request. If, however, the application is again found allowable, the issue fee can be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Issue Fee Due upon request. This request and any balance due must be received on or before the due date noted in the new Notice of Allowance in order to prevent abandonment of the application.

Telephone inquiries should be directed to Robert Dawson at (703) 306-2340.

The above-identified application is being forwarded to the examiner for prompt appropriate action, including applicant of the new status of this application.

Richard V. Fisher, Director
Technology Center 1700

09/770,289

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Cc: Allowed Files-PK3-910